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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.
AM-3245

In Re Application Of: Hoiman Raymond HUNG et al.

MAY 20 2003

PATENT & TRADEMARK OFFICE
U.S. DEPARTMENT OF COMMERCE
JCLB

Serial No.
09/276,376

Filing Date
March 25, 1999

Examiner
A. Olsen

Group Art Unit
1763

Title: ENHANCEMENT OF SILICON OXIDE ETCH RATE AND NITRIDE SELECTIVITY
USING HEXAFLUOROBUTADIENE OR OTHER HEAVY PERFLUOROCARBON

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Address to:
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Washington, D.C. 20231

37 CFR 1.97(b)

1. The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

37 CFR 1.97(c)

2. The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:

the statement specified in 37 CFR 1.97(e);

OR

the fee set forth in 37 CFR 1.17(p).

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PATENT & TRADEMARK OFFICE
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Washington, D.C. 20591-0000

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(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- A check in the amount of \$180.00 is attached.
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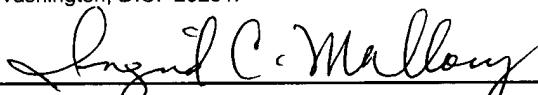
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Dated: May 12, 2003

CC:

U.S. Department of Commerce, Patent and Trademark Office				Docket No. AM-3245				
				Serial No.: 09/276,376				
LIST OF RELEVANT ART CITED BY APPLICANT (Use several sheets if necessary)				Applicant: Hoiman (Raymond) Hung et al.				
MAY 20 2003				Filing Date: March 25, 1999				
				Group: 1763				
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,117,786	09/12/00	Khajehnouri et al.	438	700		
	AB	6,297,163	10/02/01	Zhu et al.	438	707		
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
FOREIGN PATENT DOCUMENTS (Translation)								
		Document Number	Date	Country	Class	Subclass	Yes	No
	AL							
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	AN							
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
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